

N79-31179

D/B

## ADVANCED RESIN MATRICES FOR COMPOSITES

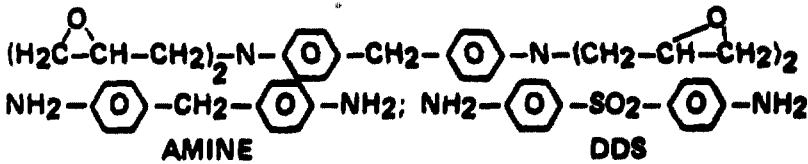
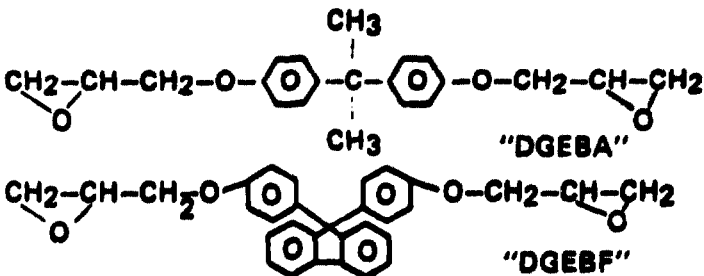
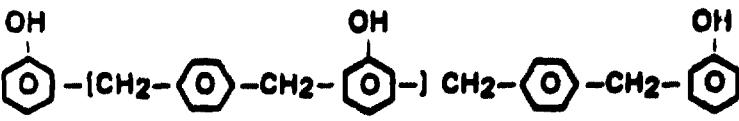
A PRESENTATION MADE AT  
THE FIREMEN MEETING  
SEATTLE, WASHINGTON  
MARCH 2, 1979

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NASA - ARC

# SELECTION CRITERIA FOR RESIN MATRICES

- HIGH CHAR YIELD
- HIGH OI, LOW SMOKE & TOXICITY
- GOOD ELEVATED TEMPERATURE MECHANICAL PROPERTIES
- GOOD THERMAL OXIDATIVE STABILITY
- HIGH HUMIDITY RESISTANCE
- CHEMICAL AND RADIATION RESISTANCE
- GOOD FATIGUE AND TOUGHNESS PROPERTIES
- COMPATIBLE PROCESSING, QUALITY CONTROL, AVAILABILITY AND COST TO STATE-OF-THE ART EPOXY RESINS

## RESIN MATRICES FOR COMPOSITES

RESIN/CURING AGENT	TYPICAL CHEMICAL STRUCTURE
<p>EPOXY RESIN BASED ON METHYLENE DIANILINE CURED WITH AROMATIC AMINE OR 4,4' DIAMINO DIPHENYL SULPHONE (DDS) (SAMPLE 1)</p>	 <p style="text-align: center;">AMINE                      DDS</p>
<p>EPOXY RESIN BASED ON DIGLYCIDYL ETHER OF BISPHENOL A (DGEBA) OR 9,9-BIS-(4-HYDROXYPHENYL) FLUORENE (DGEBF) OR BLENDS CURED WITH TRIMETHOXYBOROXINE (TMB) OR MDA OR DDS (SAMPLE 2)</p>	 <p style="text-align: center;">"DGEBA"                      "DGEBF"</p>
<p>PHENOLIC NOVOLAC RESIN BASED ON CONDENSATION OF DIMETHOXY-P-XYLENE AND PHENOL CURED WITH HEXAMINE (SAMPLE 3)</p>	

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**POLYBISMALEIMIDE PREPOLYMER  
(SAMPLE 4)**

**TYPICAL CHEMICAL STRUCTURE**

The chemical structure is a complex organic molecule. It features a central chain of aromatic rings and amide groups. The structure is symmetrical, with a central chain of aromatic rings and amide groups. The structure is symmetrical, with a central chain of aromatic rings and amide groups. The structure is symmetrical, with a central chain of aromatic rings and amide groups.

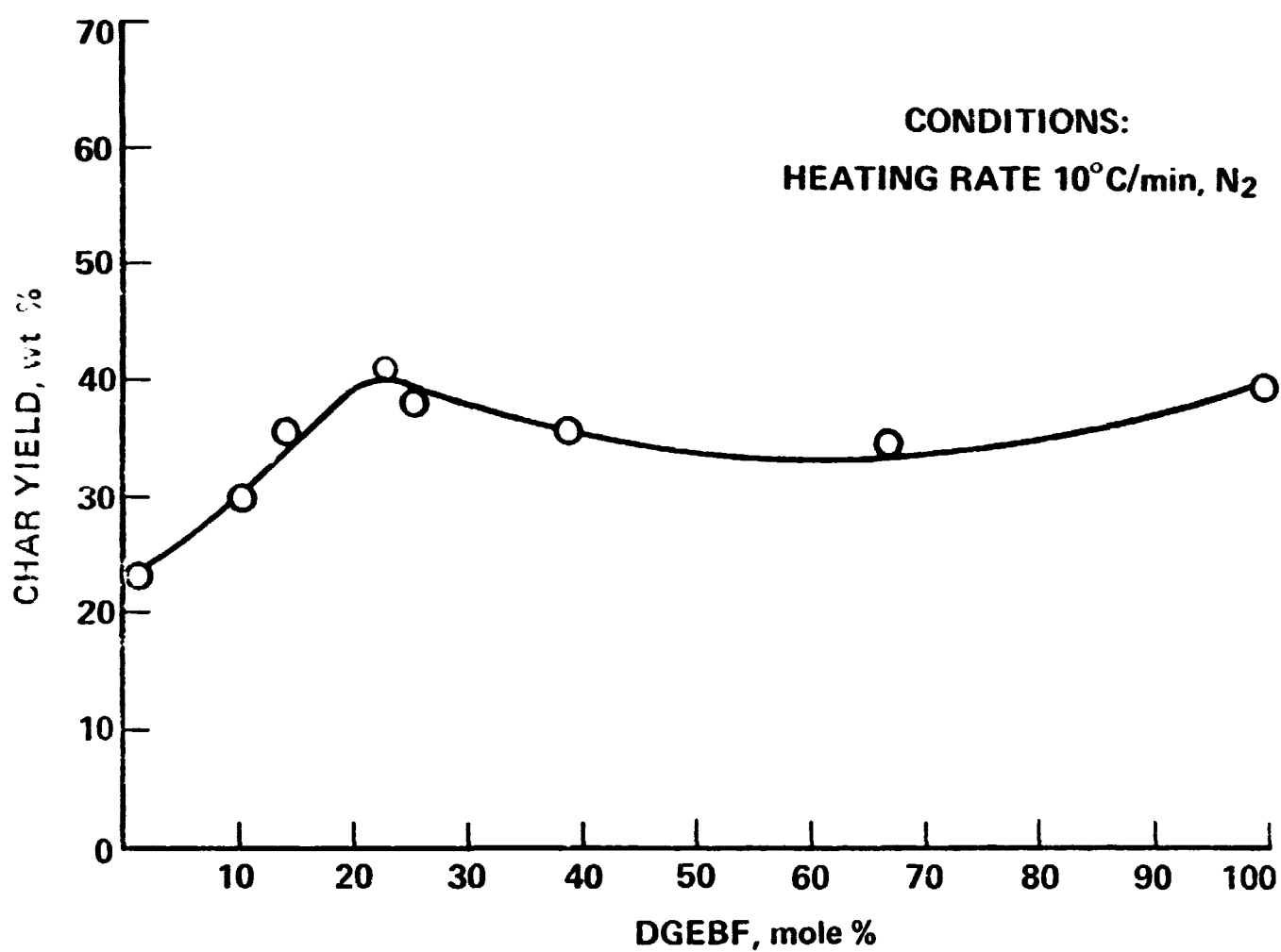
## PROCESSING CONDITIONS FOR RESINS AND LAMINATES

RESIN	PURE RESIN		
	CATALYST	CURE	POST CURE
EPOXY RESIN (SAMPLE 1)	NMA OR DEAPA OR DDS	DDS, 30 pph, 150°C – 1 hr	190°C – 4 hrs
EPOXY RESIN, DGEBA/DGEBF (SAMPLE 2)	TMB OR DDS	TMB, 30 pph, 135°C – 3 hrs	180°C – 3 hrs 218°C – 3 hrs, N <sub>2</sub>
RESIN/SOLVENT	LAMINATE		
	PREPREG	CURE	POST CURE
(SAMPLE 1)/MEK	AIR DRY, 80°C – 10 min 120°C – 20 min	163°C – 10 min, 340 KN/m <sup>2</sup> – 2 hrs	190°C – 4 hrs
(SAMPLE 2)/MEK	AIR DRY, 100°C – 15 min 140°C – 20 min	200°C – 10 min 340 KN/m <sup>2</sup> – 2 hrs	218°C – 3 hrs, N <sub>2</sub>

## PROCESSING CONDITIONS FOR RESINS AND LAMINATES

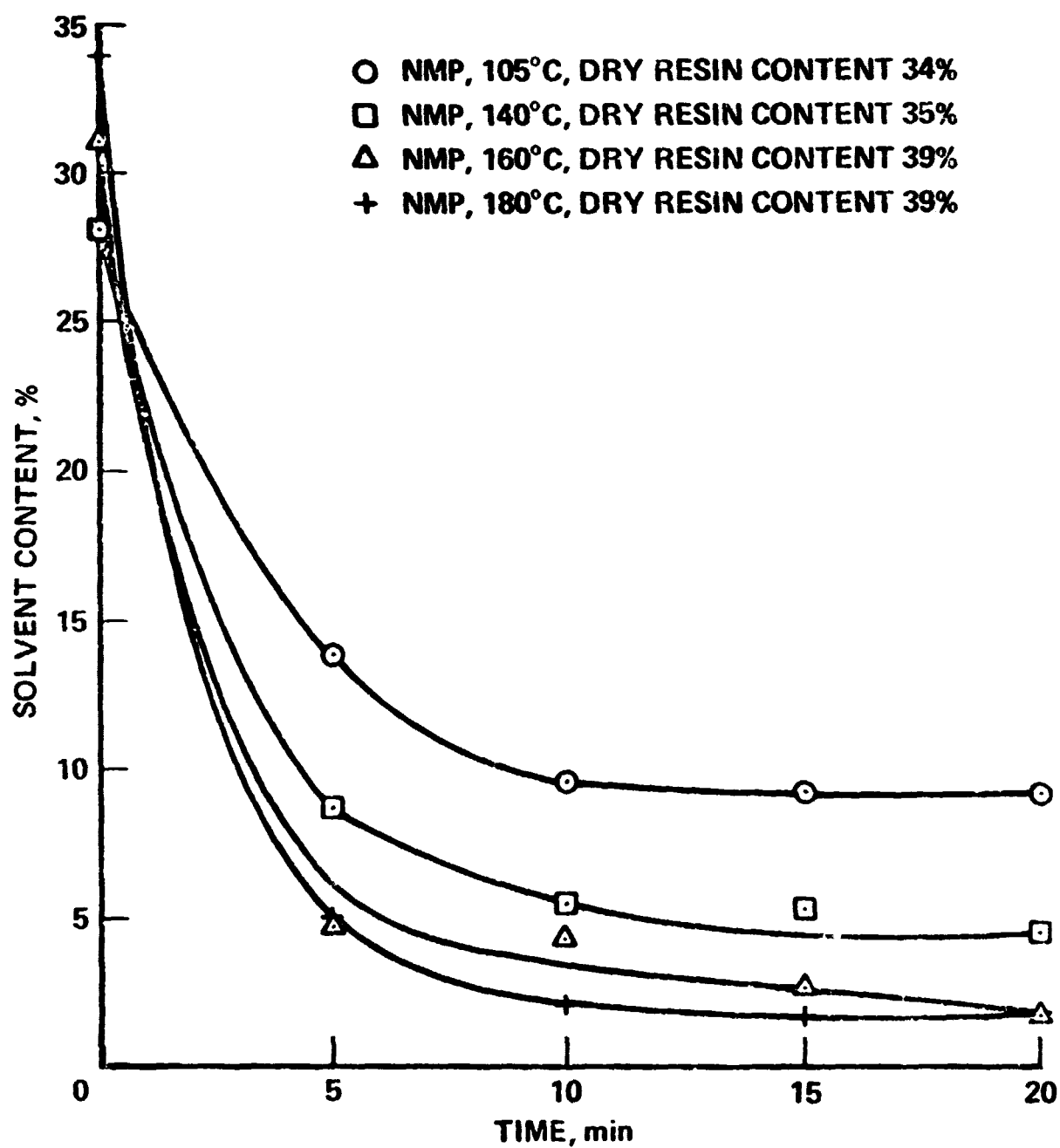
RESIN	PURE RESIN		
	CATALYST	CURE	POST CURE
PHENOLIC NOVOLAC (SAMPLE 3)		160°C – 1.5 hrs	200°C – 1 hr
POLYBISMALEIMIDE (SAMPLE 4)		200°C – 3 hrs	
PHOSPHORYLATED EPOXY (SAMPLE 5)	DEAPA	DEAPA/ BAPMP	180°C – 4 hrs
RESIN/SOLVENT	LAMINATE		
	PREPREG	CURE	POST CURE
(SAMPLE 3)/MEK	65°C – 15 min 115°C – 20 min	177°C – 1 hr 680 KN/m <sup>2</sup>	188°C – 2 hrs
(SAMPLE 4)/MEK	AIR DRY, 79°C – 15 min 120°C – 20 min	200°C – 3 hrs 680 KN/m <sup>2</sup>	
(SAMPLE 5)/MEK	AIR DRY, 80°C – 10 min 120°C – 20 min	180°C – 10 min	200°C – 4 hrs

**EFFECT OF DGEBF MOLE FRACTION IN THE  
BLEND OF DGEBA/DGEBF ON THE CHAR YIELD  
OF THE COPOLYMER AT 700°C**



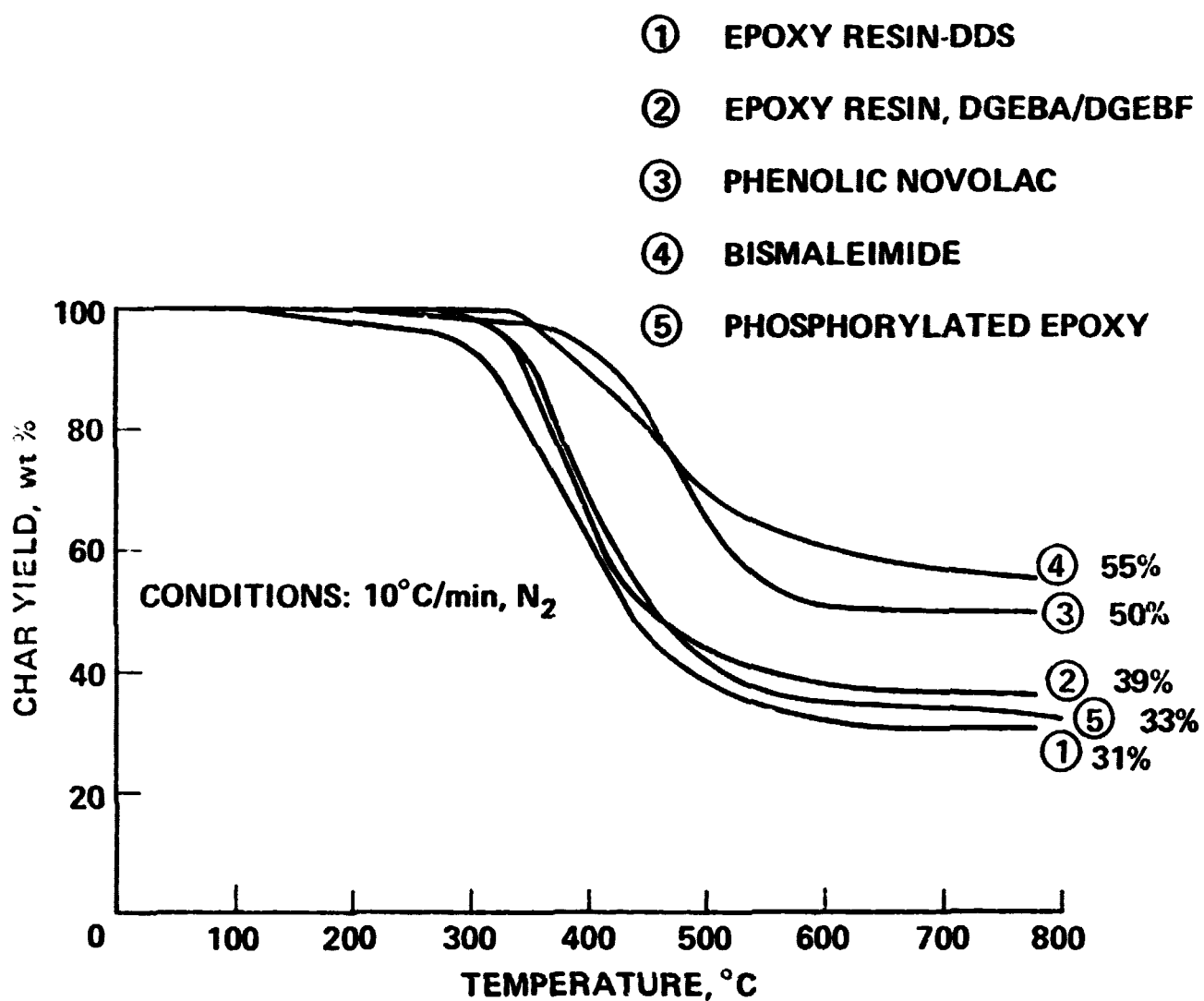
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## DRYING CURVES FOR BISMALEIMIDE/181-PREPREGS

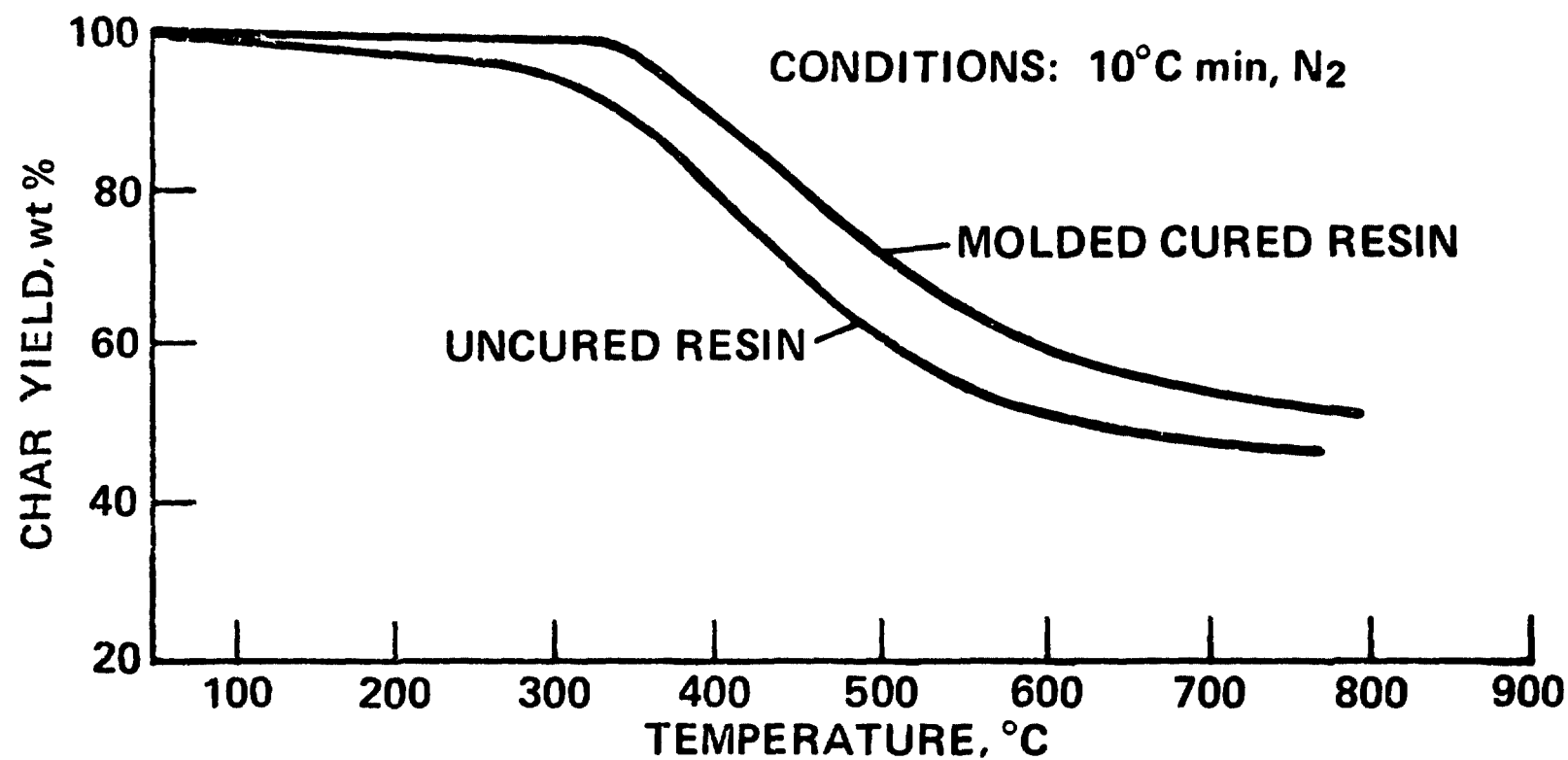




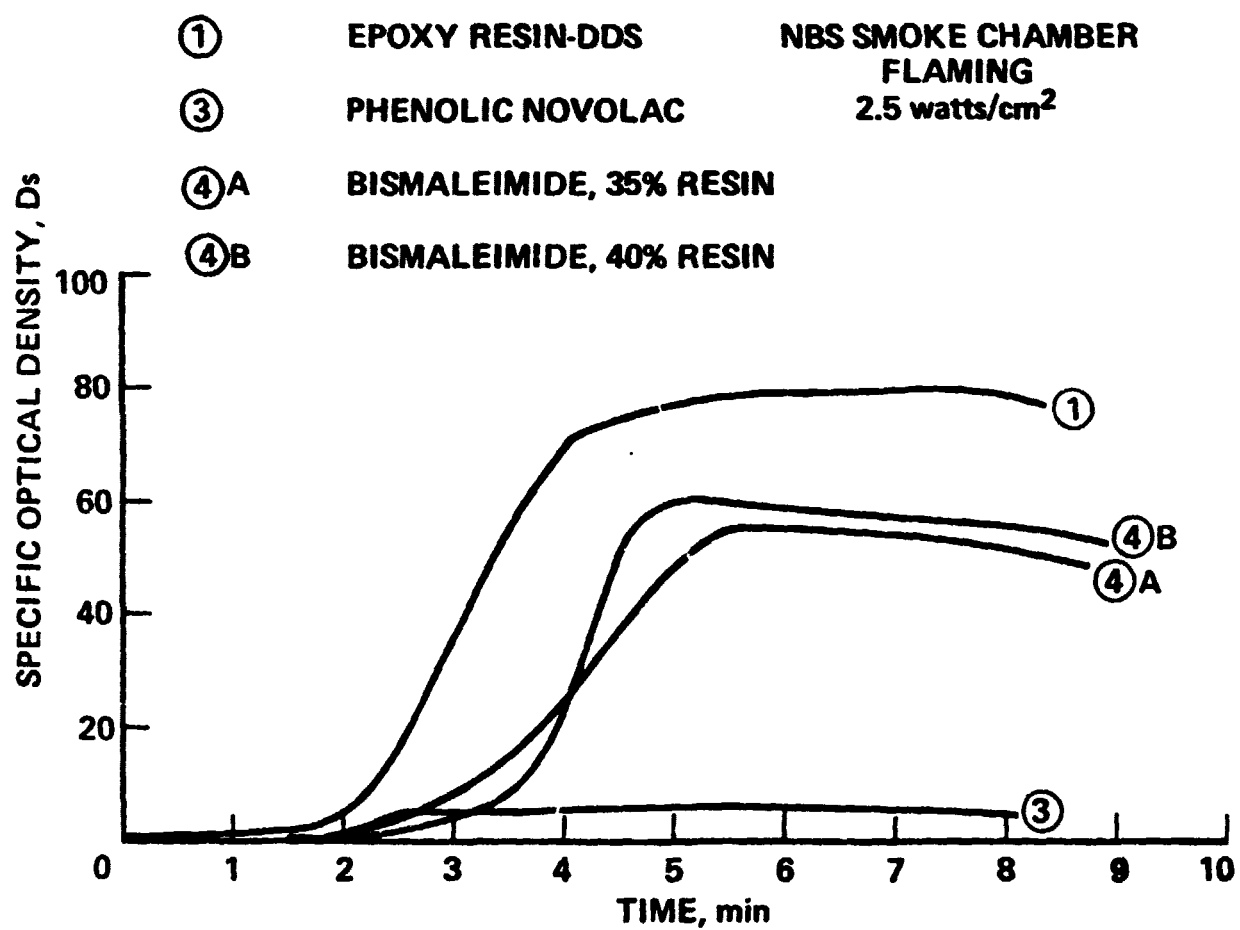
## DYNAMIC THERMOGRAVIMETRIC ANALYSES OF RESINS



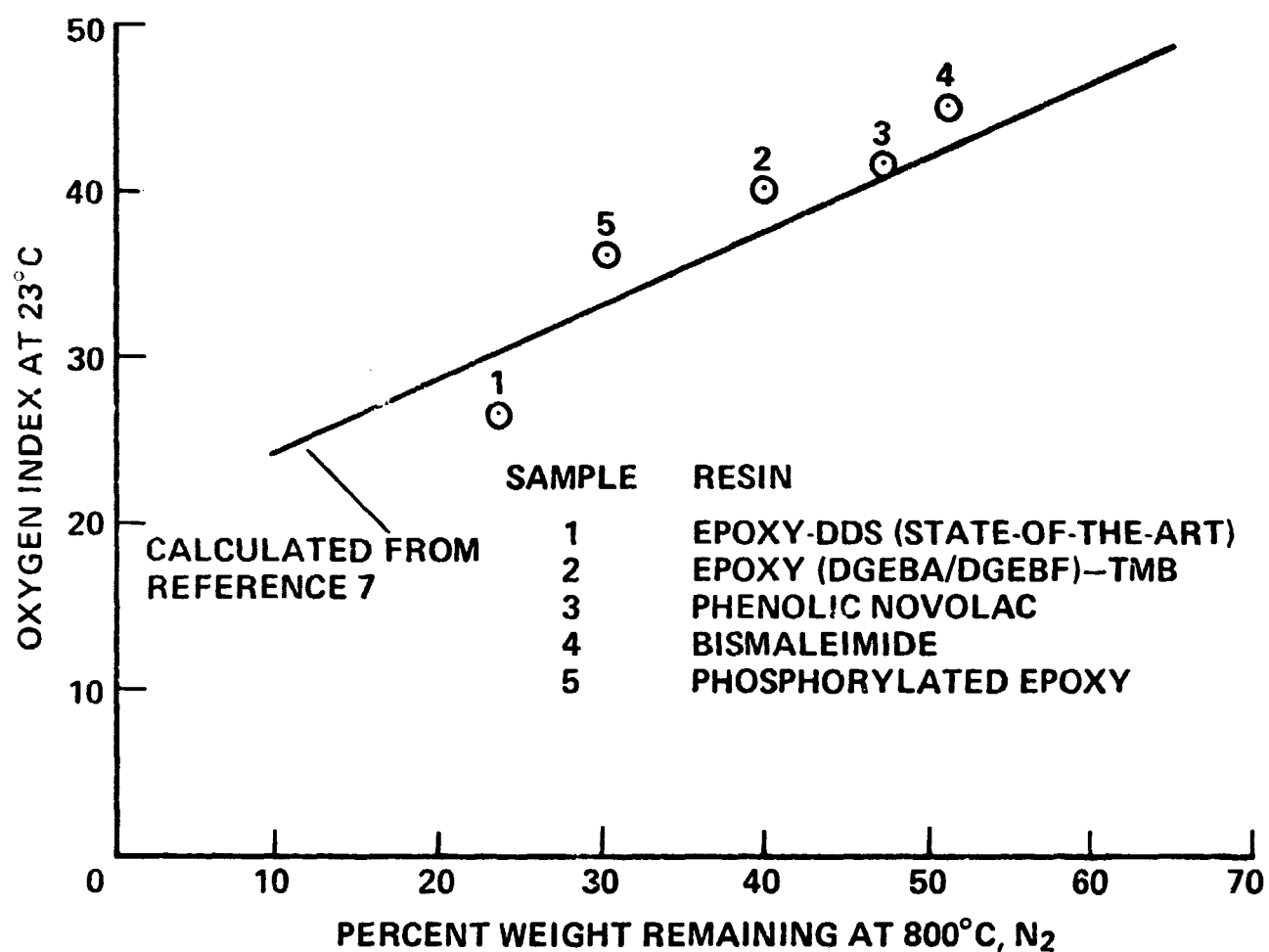
## DYNAMIC THERMOGRAVIMETRIC ANALYSIS OF BISMALEIMIDE RESIN (SAMPLE 5)



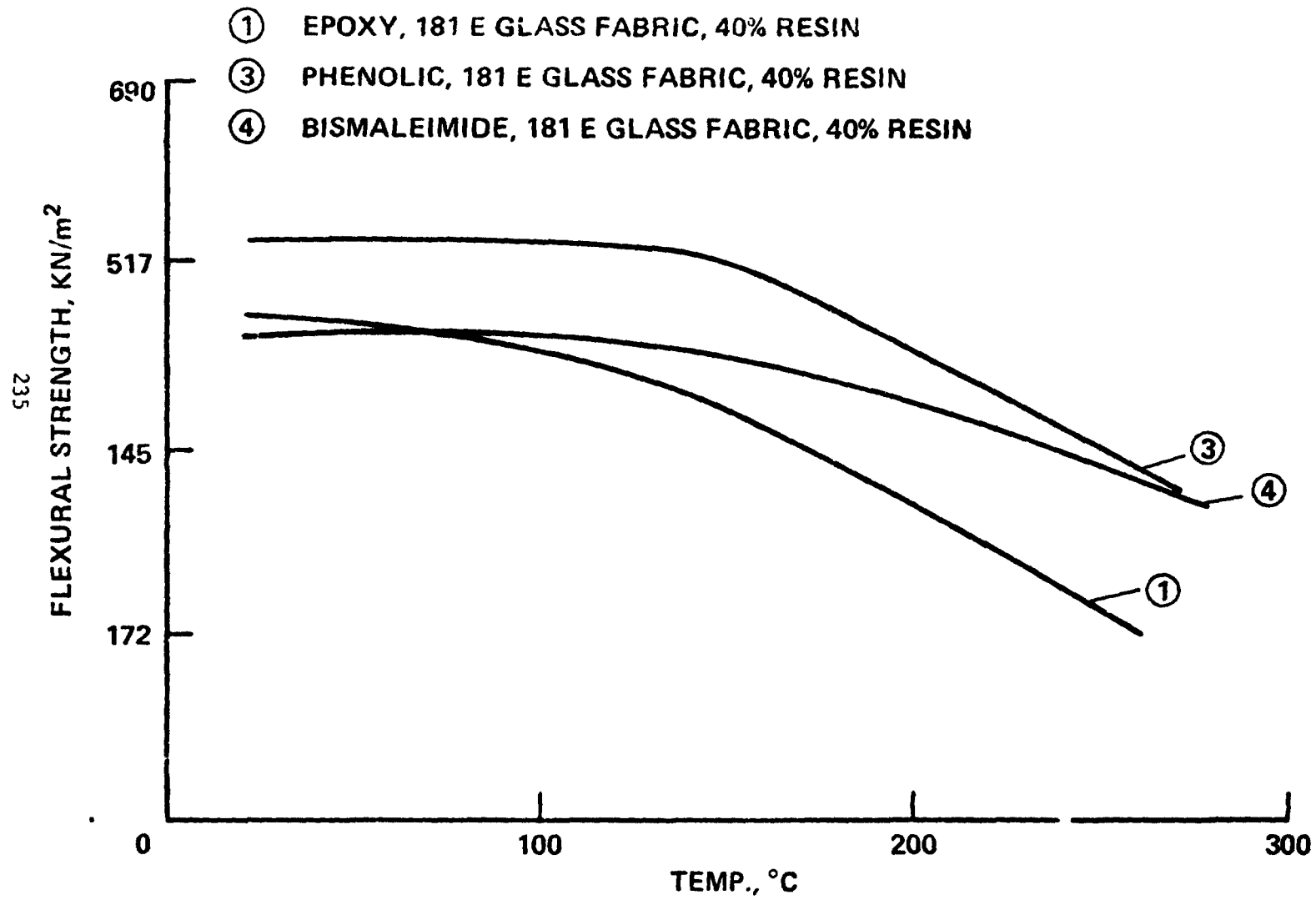
## SMOKE EVOLUTION OF RESIN/181 GLASS LAMINATES



## EFFECT OF CHAR YIELD OF THERMOSET POLYMERS ON OXYGEN INDEX



## EFFECT OF TEMPERATURE ON FLEXURAL STRENGTH OF COMPOSITES



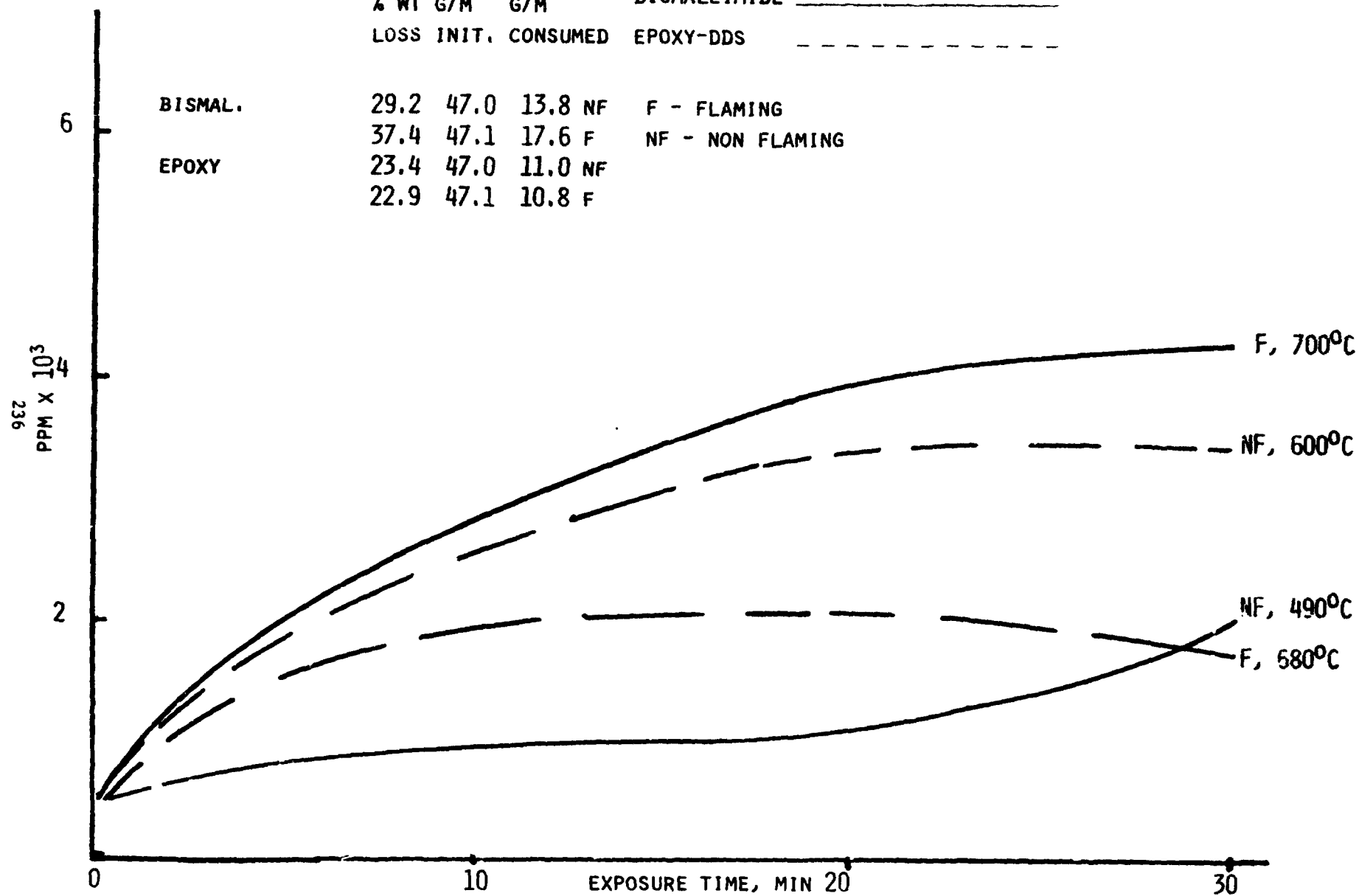
# CO CONCENTRATION HISTORY

% WT	G/M <sup>3</sup>	G/M <sup>3</sup>	BISMALEIMIDE
LOSS	INIT.	CONSUMED	EPOXY-DDS
29.2	47.0	13.8	NF
37.4	47.1	17.6	F
23.4	47.0	11.0	NF
22.9	47.1	10.8	F

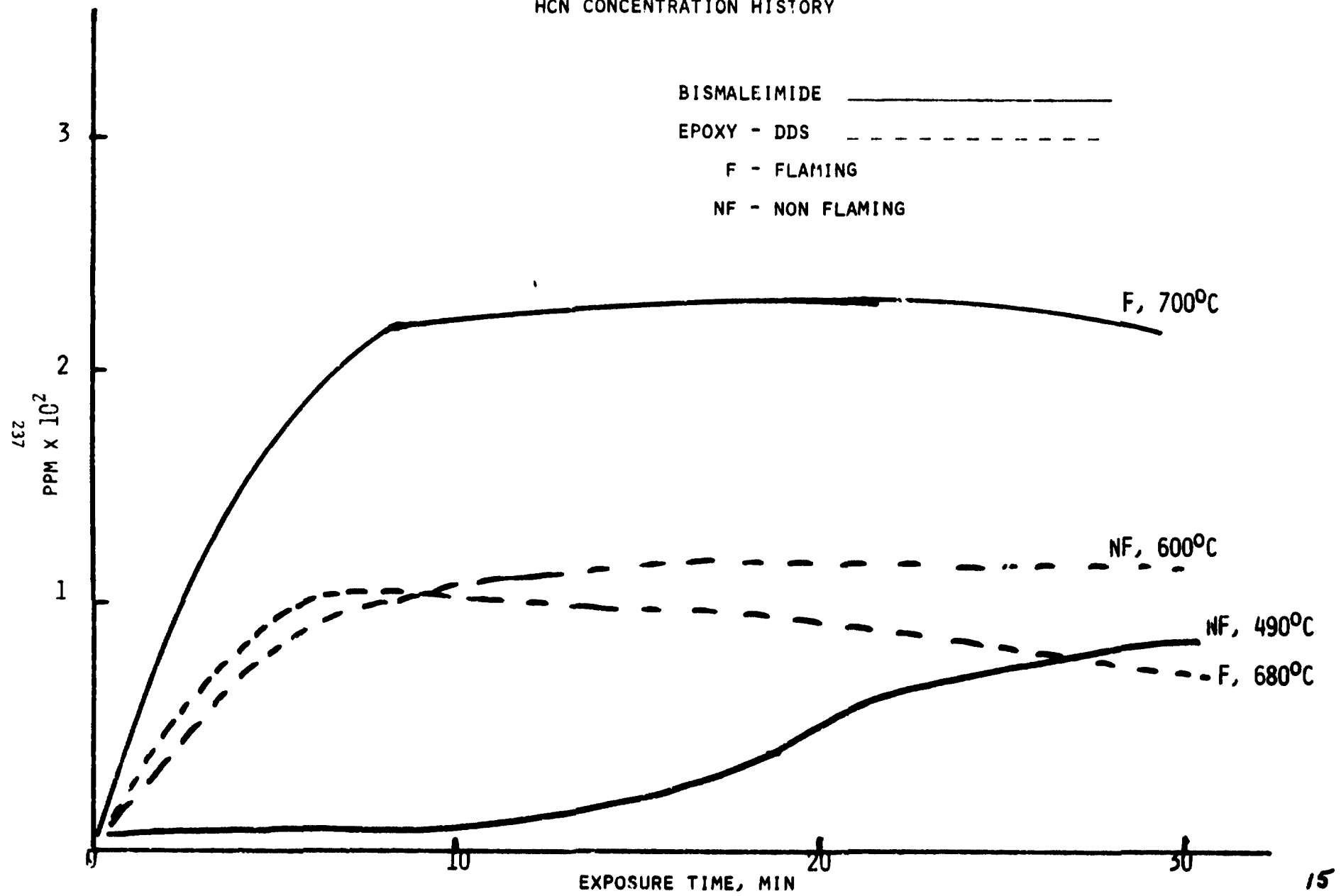
BISMAL.

F - FLAMING  
NF - NON FLAMING

EPOXY



# HCN CONCENTRATION HISTORY



### CONCLUSIONS

DGEBA/DGE.BF EPOXY CURED WITH TMB EXHIBITED HIGHEST  $\text{OI}$  AND  $\gamma_c$  THAN ALL OTHER EPOXY RESINS WITH PROCESSING PARAMETERS COMPARABLE TO CONVENTIONAL EPOXIES.

PHENOLIC-NOVOLAC RESIN EXHIBITED LOWEST  $D_s$  THAN ALL OTHER RESIN SYSTEMS.

BISMALEIMIDE RESIN EXHIBITED HIGHEST  $\text{OI}$  AND  $\gamma_c$  THAN ALL OTHER RESIN SYSTEMS. PROCESSING PARAMETERS COMPARABLE TO PHENOLICS.

ABOVE RESINS EXCELLENT CANDIDATES FOR RESIN MATRICES FOR GLASS OR GRAPHITE COMPOSITES.